Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/720,056	CHA, KI CHUL	
Examiner	Art Unit	
Jason Heckert	1746	

SEARCHED							
Class	Subclass	Date	Examiner				
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INTERFERENCE SEARCHED						
Class	Subclass	Date	Examiner			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Consulted J. Perrin	8/7/2007	ЈМН		
Updated Search	8/8/2007	JMH		
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